

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fumihiko Nakamura, et al.

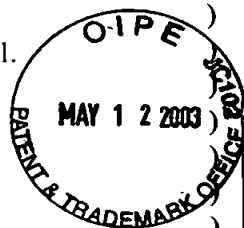
Application No. 09/925,153

Filed: August 8, 2001

For: "INSULATING NITRIDE LAYER  
AND PROCESS FOR ITS FORMING, AND  
SEMICONDUCTOR DEVICE AND  
PROCESS FOR ITS PRODUCTION"

) Group Art Unit 2813

) Examiner: D. Blum



I hereby certify that this document is being deposited  
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*Karen Turkowski*  
Karen Turkowski

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Commissioner of Patents  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136**

Dear Sir:

Applicant hereby petitions the Commissioner of Patents and Trademarks to extend the period for response to the office Action dated November 5, 2002, for three month(s) so that the period for response is extended to May 5, 2003.

The Commissioner is hereby authorized to charge the amount of \$930.00 to cover the three-month extension fee to American Express Account No. 3785-716974-01002 CH and to charge any deficiency to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Dated: May 5, 2003

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